

PATENT Customer No. 22,852

Attorney Docket No. 08137.0004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1762

Examiner: B. Chen

In re Application of:

Hiroshi SHINRIKI et al.

Serial No.: 09/657,627

Filed: September 8, 2000

For:

Sir:

THIN FILM FORMING METHOD

AND THIN FILM FORMING

APPARATUS

Commissioner for Patents and Trademarks

Washington, DC 20231

TC 1700

PETITION FOR EXTENSION OF TIME

Applicants hereby petition for a three month extension of time to reply to the Office Action of June 20, 2001. A fee of \$920.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: December 20, 2001

David W. Hill

Reg. No. 28,220

FINNEGAN HENDERSON FARABOW DUNNER LLP

1300 I Street, NW Washington, DC 20005 202.408.4000 Fax 202.408.4400

12/21/2001 EABUBAK1 0000055 09657627

01 FC:117

920.00 OP